

<b>Electronic Patent Application Fee Transmittal</b>				
<b>Application Number:</b>	10567173			
<b>Filing Date:</b>	03-Feb-2006			
<b>Title of Invention:</b>	Offset dependent resistor for measuring misalignment of stitched masks			
<b>First Named Inventor/Applicant Name:</b>	Joseph M. Amato			
<b>Filer:</b>	Mark Alan Wilson			
<b>Attorney Docket Number:</b>	US03 0199 US2			
Filed as Large Entity				
<b>U.S. National Stage under 35 USC 371 Filing Fees</b>				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
Independent claims in excess of 3	1614	3	220	660
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
<b>Post-Allowance-and-Post-Issuance:</b>				
<b>Extension-of-Time:</b>				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
<b>Total in USD (\$)</b>				<b>660</b>